

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	DOCKET NO: 52433/828	SERIAL NO. <del>Not Yet Assigned</del>
	APPLICANT Nonaka et al.	
	FILING DATE Herewith	GROUP <del>Not Yet Assigned</del> 1793

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/D.Y./	2003-193192	July 9, 2003	Japan			Abstract	
↓	2003-239040	August 27, 2003	Japan			Abstract	
↓	2000-345288	December 12, 2000	Japan			Abstract	
↓	2001-234281	August 28, 2001	Japan			Abstract	

**OTHER DOCUMENTS**

EXAMINER INITIAL		AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.

EXAMINER     /Deborah Yee/	DATE CONSIDERED     01/08/2008
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>	



**SUPPLEMENTAL  
INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
PTO-1449**

DOCKET NO.  
52433/828

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Nonaka et al.

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December 14, 2005

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**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE*

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	EP 0750049 A1	December 27, 1996	Europe				X
	EP 0748874 A1	December 18, 1996	Europe				X
	EP 0796928 A1	September 24, 1997	Europe				X
	JP 2000256788 A	September 19, 2000	Japan			Abstract	
	EP 1431406 A1	June 23, 2004	Europe				

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Olaf Maid et al., Einfluss der Herstellungsbedingungen von Wrm- und Kltband auf die Gefugeausbildung und die mechanischen eigenschaften von Dalphasen- Stahl, Stahl und Eisen, vol. 108, no. 8, April 18, 1988, pages 31-36

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